PATENT Atty. Dkl AMAT/3819/DSM/BCVD/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of.

Suzuki, et al.

Serial No.: 10/004,489

Confirmation No.: 9428

Filed:

October 23, 2001

For:

Method of Forming Film, Method of Manufacturing Semiconductor Device and Film Forming Apparatus

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Group Art Unit: 2818

Examiner: Renee R. Berry

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Dear Sir.

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PETITION FOR WITHDRAWAL FROM ISSUANCE UNDER 37 C.F.R. §1.313(c)(3)—EXPRESS ABANDONMENT

Applicants petition under Rule 313(c)(3) for withdrawal of the application from issuance for express abandonment of the application. The Commissioner is hereby authorized to charge the petition fee of \$130.00 to Deposit Account No. 20-0782/AMAT/3819/KMT.

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Respectfully submitted,

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P.001/003 F-851

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☐ YES 🖾 NO

PETITION FOR WITHDRAWAL FROM ISSUANCE UNDER 37 C.F.R. (c)(3) AND EXPRESS ABANDONMENT AFTER PAYMENT OF ISSUE FEE

TITLE:

Method of Forming Film, Method of Manufacturing

Semiconductor Device and Film Forming Apparatus

U.S. SERIAL NO.:

10/004,489

FILING DATE:

October 23, 2001

INVENTOR:

Suzuki, et al.

EXAMINER:

Renee R. Berry

GROUP ART UNIT: CONFIRMATION NO.: 2818 9428

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